

# The con-focal method on verifying focal plane of MAS machine: erratum

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**Abstract:** Correction to author listing and affiliations.

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## References and links

1. W. Huang and F. Cerrina, " The con-focal method on verifying focal plane of MAS machine," Opt. Express **15**, 872-877 (2007). <http://www.opticsinfobase.org/abstract.cfm?URI=oe-15-3-872>

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The author listing and affiliations for the previous article [1] should read:

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